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# One-step fabrication of functionalized electrodes on 3D-printed polymers for triboelectric nanogenerators

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## ABSTRACT

Triboelectric nanogenerators (TENGs) have gained remarkable attention in energy harvesting and smart sensing, allowing for converting mechanical energy into electrical energy. Despite great potential and progress made in this field, there remains a high demand for high-performance electrodes that are produced with sustainable, low-cost, lightweight, and durable materials such as polymers. Here, by combining the material extrusion 3D printing and the cold spray particle deposition methods, we employ a complete additive manufacturing (AM) approach to fabricate functionalized electrodes on 3D-printed parts for TENG technology. First, polylactic acid (PLA) parts were produced by material extrusion printing. Next, the cold spray process (CS) was utilized as just a one-step fabrication method of the conductive electrodes on the printed parts, eliminating the need for surface activation, over-plating, curing, and/or post-processing. Additionally, the process-structure-property relationships of the CS process were uncovered to fabricate high-performance electrodes for TENGs. The resulting electrodes demonstrate promising electrical conductivity ( $9.8 \times 10^4 \text{ S.m}^{-1}$ ), adhesive strength, stability, and micro-roughness ( $R_a = 6.32 \text{ }\mu\text{m}$ ). The TENG with the fabricated electrode generates an open-circuit voltage of 174 V, which is nearly 1.85–2.9-fold higher than that of the control TENGs. It achieves the short-circuit density of  $\approx 55 \text{ mA/m}^2$ , and the power density of  $1676 \text{ mW/m}^2$ . Besides, to address the low-spatial resolution of the cold spray metallization, a manufacturing pathway is proposed, aiming to achieve higher line resolution (1 mm linewidth) electrodes for polymer electronics. This work provides a manufacturing strategy that can advance the field of TENG and polymer electronics by addressing the limitations of conventional electrode manufacturing techniques.

## 1. Introduction

Triboelectric nanogenerator (TENG) – a state-of-the-art energy harvesting device – presents opportunities to effectively harness abundant

surrounding mechanical energy sources into electrical energy [1,2]. Owing to its high efficiency, simplicity, and low cost, TENG has been proven as a viable energy harvesting technology in many applications, including micro/nano energy harvesting [3], active and smart sensing [4,5], self-powered sensors [6], smart home applications [7], blue

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| Nomenclature         |                         |          |                                       |
|----------------------|-------------------------|----------|---------------------------------------|
| A                    | Area                    | CV       | Cyclic voltammetry                    |
| L                    | Length                  | EDX      | Energy-dispersive X-ray               |
| R                    | Resistance              | $I_{sc}$ | Short-circuit current                 |
| $R/R_0$              | Relative resistance     | ITO      | Indium tin oxide                      |
| $R_s$                | Sheet resistance        | ITO-PET  | ITO coated polyethylene terephthalate |
| S                    | Siemens                 | LED      | Light emitting diode                  |
| $\rho$               | Resistivity             | Pd       | Palladium                             |
| $\Omega$             | Ohm                     | PLA      | Poly(lactic acid)                     |
| <b>Abbreviations</b> |                         | PTFE     | Polytetrafluoroethylene               |
| AM                   | Additive manufacturing  | RT       | Room temperature                      |
| CS                   | Cold spray              | SEM      | Scanning electron microscopy          |
| CSC                  | Charge storage capacity | Sn       | Tin                                   |
|                      |                         | $V_{oc}$ | Open-circuit voltage                  |

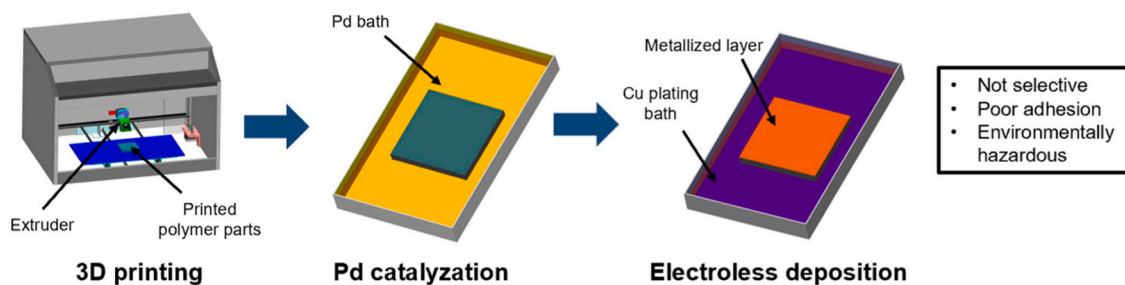
energy [1], etc. The working mechanism of TENG lies in contact electrification and electrostatic induction [8]. In principle, when two materials with opposite polarities come into contact and then separate or slide each other, electron transfer takes place between the materials, which can be harvested through an external circuit [3]. Herein, the output performance of TENG strictly relies on electrostatic induction between the friction layers and electrodes [9,10]. In this regard, many attempts have been made to improve the TENG performance by employing various materials, such as metal films, polymers, composites, and micro- and nanostructured materials [11–13].

Among others, electrodes on polymer substrates are of particular interest to improve energy harvesting efficiency for TENG as they are sustainable, durable, lightweight, and low-cost [14–16]. These electrodes are mainly produced by lithography [17], vapor deposition [18], screen printing [19], ink-jet printing [20], and laser-induced

metallization [21]. In these methods, functional materials are deposited on the base polymeric substrate to constitute conductive electrodes embedded on the surface. An ideal polymer electrode for high-performance TENG should possess: i) micro-rough surface morphology to increase the contact area; ii) strong adhesive strength between the functional surface coating and substrates; iii) stable electrical conductivity; and iv) durability under severe friction. All these features are integral to creating high-performance and durable TENGs. However, traditional manufacturing methods face challenges in creating high-performance electrodes due to the need for additional sources or processes, such as high temperature, vacuum, over-plating (e.g., electroless deposition), precursor, or post-sintering processes.

As shown in Fig. 1a, the traditional manufacturing process of functional electrodes on polymer substrates lies in the metallization process, often involving environmentally hazardous surface pretreatment and

### (a) Conventional method



### (b) This study

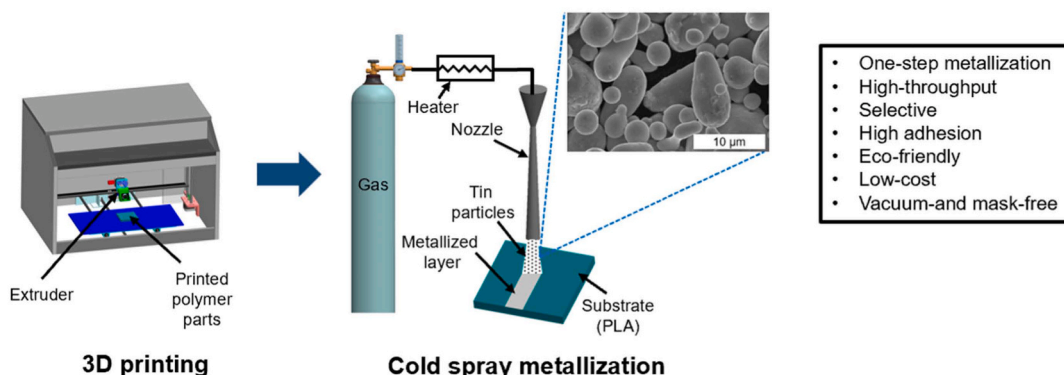


Fig. 1. Schematics of the (a) traditional polymer metallization approach; (b) the additive manufacturing approach in this study.

cost-intensive palladium (Pd) seeding processes [22]. These demanding surface treatment processes impede the sustainable utilization of this approach in producing functionalized electrodes on polymer parts. Recently, additively manufactured electrodes have gained considerable attention in energy harvesting applications [23] due to their flexible, accurate, and low-cost manufacturing practices through rapid prototyping [24–26]. Particularly, commercial conductive filaments (e.g., Proto Pasta, Black Magic, Electrifi) enabled rapid prototyping of 3D-printed electrodes [27,28]. However, these conductive filaments have poor conductivity, which is generally 3750 times lower than the standard bulk copper (i.e.,  $58.7 \times 10^6 \text{ S.m}^{-1}$ ) [29], thereby limiting the utilization of the 3D-printed electrodes in energy harvesting applications. Some studies [30–32] integrated 3D printing with conductive filaments and subsequent surface metallization process through electroless or electro-plating. Even though these attempts led to improved electrical conductivity, these methods often employ cost-intensive catalyst (e.g., palladium) embedded filaments with additional process steps such as over-plating. As such, a critical need is identified for the non-traditional additive manufacturing (AM) method that may enable sustainable and high-throughput production of functionalized electrodes embedded on 3D-printed polymers for energy harvesting applications, including TENGs and the like.

Recently, the authors' group has deployed and studied the emerging cold spray (CS) particle deposition technique to create enhanced-performance TENGs [6,33]. In these studies, functional surfaces were produced on flexible polymers (i.e., PTFE, PET films) as the triboelectric friction layer and electrode. Furthermore, the CS process has been recently proposed to create counter electrodes on 3D-printed polymers for dye-synthesized solar cell applications [34]. These initial proof-of-the-concept results revealed the remarkable potential of the CS in the field of energy harvesting. Building on these earlier findings, this study, as shown in Fig. 1b, employs the CS technique to achieve one-step fabrication of functionalized electrodes on 3D-printed polymers. Furthermore, the study investigates the process-structure-property relationships of CS for TENGs and polymer electronics.

Initially, the polymer substrate is rapidly prototyped through material extrusion. Subsequently, fine metal particles are directly written on the as-printed polymer surface via the CS to create the functionalized electrodes (Fig. 1b). Owing to the unique properties of the CS- including low-process temperature, high-adhesion strength, corrosion resistance, and durability [35–37]- this approach ensures the creation of sustainable and high-performance electrodes on 3D-printed polymer parts. The resulting electrodes are characterized in terms of microstructure, electrical conductivity, adhesion strength, stability, and catalytic activity. Furthermore, TENG devices are fabricated to evaluate the performance of the electrodes against traditional electrode material such as aluminum. Lastly, a manufacturing pathway is proposed to address the low-spatial resolution of the CS metallization, aiming to achieve higher line resolution electrodes (1 mm linewidth). The proposed manufacturing approach further underscores the potential of the CS technique in polymer electronics. As such, this study unveils the potential of a complete AM approach that allows for one-step functional metallization of 3D-printed polymers in the realm of polymer electronics and energy harvesting with TENGs.

## 2. Experimental section

### 2.1. Materials

Polylactic acid (PLA) filament was used for rapid prototyping of the polymer substrate through the material extrusion 3D printing method. PLA was chosen as the substrate due to its recyclability, composability, and low melting point, all of which make PLA a highly desired material in numerous applications [38]. Moreover, PLA is favorably positioned in the triboelectric series, tending to acquire positive charge when rubbed against counter materials [39]. Additionally, PLA can function as both

negative and positive material in TENG applications, depending on its counter material [40]. Notably, PLA's biodegradability and ease of printing make it particularly attractive for triboelectric energy harvesting applications. It was also demonstrated that conductive carbon filled PLA can be used to create fully enclosed microbead-structured TENG arrays, resulting in enhanced energy harvesting performance [41].

In the CS process, tin (Sn) powders were selected as the feedstock material due to its low strain hardening and high softening rates [42, 43]. These properties facilitate metallurgical bonding of Sn particles onto the polymer surface compared to the pure aluminum (Al) powders. As such, achieving electrically conductive layers (electrodes) on 3D-printed parts using Al particles poses challenges in contrast to Sn feedstock, resulting in inferior performance in TENG applications (see Fig. S1, Supporting Information). Additionally, Sn has high corrosion resistance, making it as a promising functional material for TENGs and polymer electronics [6,44]. Taken together, Sn powders were chosen in this study to fabricate CS-based electrodes in TENG applications. The morphology of the Sn powders is shown in Fig. 1b (right panel), having a quasi-spherical shape in a size range of 10–45  $\mu\text{m}$  [43]. In TENG fabrication, PLA substrate with a thickness of 1 mm was cold sprayed to deposit Sn electrode. Conventional Al foil with two different thickness,  $\approx 152 \mu\text{m}$  (McMaster, Part No: 9708K56) and  $16 \mu\text{m}$  (Reynolds), was employed in the control TENGs as the electrode material for performance studies. Notably, 152  $\mu\text{m}$ -thick Al film has a comparable thickness to the as-CS Sn electrode, while the 16  $\mu\text{m}$ -thick Al film was used for further characterization, as it falls within the widely-used thickness range for friction layers in TENG applications. All the materials used, including those for the cyclic voltammetry test and TENG fabrication for performance comparison, are 'as-received' without any further purification as listed Table 1.

### 2.2. Methodology

Fig. 1b illustrates the proposed AM approach of functionalized electrodes deposited on the 3D-printed polymer parts. First, the polymer substrate (PLA) is rapidly prototyped through material extrusion. Next, the polymer surface is directly metallized by the CS method. Unlike the traditional polymer metallization methods, the proposed approach enables one-step metallization of 3D-printed parts without the need for environmentally hazardous strong acid etching and cost-intensive Pd absorption processes. Moreover, owing to the unique properties of the CS, including low-process temperature, high-adhesion strength, and minimal thermal degradation, this approach ensures sustainable and high-throughput surface metallization on 3D-printed parts in a selective, cost-effective, and vacuum-free manner. In the next sub-sections, each step in the proposed AM approach is described in detail.

#### 2.2.1. Material extrusion 3D printing

The polymer substrates were fabricated using a rapid prototyping approach based on material extrusion due to its ease of use, prototyping accuracy, and low cost [45]. The parts are produced by a 3D printer

**Table 1**  
Materials used in this study.

| Process                                       | Materials   | Supplier        |
|---|---|-----------------|
| Material extrusion 3-D printing               | PLA   | Sindoh Inc.     |
| Cold spray metallization                      | Tin (Sn) particles  | Centerline Ltd. |
| Cyclic voltammetry (CV) test                  | Lithium iodide (LiI); Iodine (I <sub>2</sub> ); Lithium perchlorate (LiClO <sub>4</sub> ); Acetonitrile | Sigma-Aldrich   |
| TENG fabrication (for performance comparison) | PTFE film, Polyimide, Aluminum tape, Foam tape; Reynolds aluminum foil                                  | McMaster Amazon |

(*Sindoh 3DWOX*) with a single nozzle configuration on a heated bed with a temperature of 90 °C. The extruder temperature and the thickness of each layer were set to 200°C and 0.2 mm, respectively. Under these 3-D printing conditions, the PLA substrate with a thickness of 1 mm was produced to be used as the electrode material in TENGs. The surface roughness of the fabricated bare PLA substrates is measured as  $R_a = 2.85 \pm 0.75 \mu\text{m}$ . The operational settings of the 3D printing process are presented in Table 2.

### 2.2.2. Cold spray (CS) direct writing

The surface of the 3D-printed PLA parts was functionally metallized for TENG application via the CS method. In this regard, micron-scale Sn particles were deposited on the PLA surface using a low-pressure CS machine (*Rus Sonic Technology, Model K205/407 R*) mounted on a programmable multi-axis robot arm to precisely control the surface deposition process. A rectangular-shaped nozzle was used in particle deposition experiments for large-area metallization owing to its larger exit aperture (10.35 mm × 3 mm). A representative image of the entire CS setting is presented in Fig. 2a. To investigate the process-structure-property relationships of the CS deposition on 3D-printed PLA surface, various gas conditions (*i.e.*, inlet pressure, temperature) and kinematical settings (*i.e.*, nozzle speed, spray distance) were considered as listed in Table 3.

### 2.3. Characterization methods

Scanning electron microscopy (*SEM, Hitachi S-4800*) was used to analyze the microstructural morphology of the resultant metallization. The chemical composition of the resultant electrodes was characterized by the energy-dispersive X-ray (EDX) (*Hitachi S-4800*). The electrical resistance of the fabricated electrodes was measured by the two-point probe method using a digital multimeter (*Agilent/HP 34401A*). Moreover, a four-point probe system (*Jandel, RM3-AR*) was used to characterize the sheet resistance. The cyclic voltammetry (CV) tests were also performed to analyze the catalytic and electrochemical activity of the electrodes through a potentiostat (*SP-200, Bio-Logic Inc, Seyssinet-Pariset, France*). The Scotch (*3 M magic tape*) tape test method was applied to investigate the adhesive strength of the electrodes. The surface roughness was measured by a surface roughness tester (*AMTAST*). A custom-build programmable pneumatic actuator, coupled with an oscilloscope (*Agilent, DSO1014A*), was used to measure the open-circuit voltage ( $V_{oc}$ ). The short-circuit current ( $I_{sc}$ ) was measured using a current amplifier (*Edmund Optics*) connected to the oscilloscope.

## 3. Results and discussion

### 3.1. Optimal operational conditions of the CS

Identifying optimal operational conditions for the CS is vital for precisely fabricating the electrodes on the 3D-printed parts. To achieve this, we selected and studied the governing operational parameters of the CS process in terms of driving gas pressure (P), gas temperature (T), spray distance (SD), and nozzle speed (NS). Fig. 3a–c present the effect of these CS parameters on the electrical resistance of the fabricated

electrodes in a range of  $P = 0.6\text{--}0.7 \text{ MPa}$ ,  $T = 25\text{--}150 \text{ °C}$ ,  $SD = 5\text{--}40 \text{ mm}$ , and  $NS = 100\text{--}300 \text{ mm/s}$ . These tests were conducted for two different pressure levels at  $P = 0.6$  and  $0.7 \text{ MPa}$ . The gas temperatures were measured near the nozzle surface close to the exit section under steady-state conditions using an infrared thermal camera (*FLIR A300*). The temperature distribution along the nozzle at various temperature settings is provided in Fig. S2, (Supporting Information).

Fig. 3a shows that no electrical conductivity was achieved at room temperature (25 °C) without preheating the gas. Even though particles were locally impinged into the target surface, no continuous metallurgical bonding was observed (see Fig. S3, Supporting Information). The reasons are: i) insufficient particle impact velocity for metallurgical consolidation; and ii) poor thermal softening due to a low process temperature [46]. Conductive metallization on the polymer surface was achieved at  $T \geq 80 \text{ °C}$ . This can be attributed to the increase in kinetic energy of particles at elevated gas temperature, which facilitated material consolidation on the polymer surface (see Fig. 4a–b). The colored cross-section SEM image in Fig. 4g also indicates that the particles effectively impinged into the polymer interface at  $T = 80 \text{ °C}$  and  $P = 0.7 \text{ MPa}$ . As the gas temperature was further increased, no remarkable change in electrical resistance was observed. However, local erosions were inspected on the polymer surface due to the elevated process temperatures, such as at  $T = 150 \text{ °C}$  (see Fig. S4, Supporting Information).

Regarding nozzle speed, Fig. 3b demonstrates that resistance tends to increase with higher nozzle speeds. It is attributed to reduced particle deposition on the polymer surface due to the short spraying time at higher nozzle speeds. The lowest resistance was achieved at the  $NS \leq 150 \text{ mm/s}$ , while resistance sharply increased at  $NS > 150 \text{ mm/s}$ . The microstructure analysis in Fig. 4c reveals significant porosity on the target surface at  $NS = 250 \text{ mm/s}$  and  $P = 0.6 \text{ MPa}$ , where Sn particles are locally impinged into the polymer (see Fig. S5a, Supporting Information). The high porosity impedes the continuous junctions among the Sn particles, resulting in limited or no conductivity. Even though higher pressures ( $P = 0.7 \text{ MPa}$ ) at  $NS = 250 \text{ mm/s}$  led to a coated surface with less porosity as shown in Fig. 4d, the electrical resistance significantly raised to over  $100 \Omega$  under these process conditions (see Fig. 3b). The cross-section SEM analyses in Fig. 4h–i reveal that the particles not fully impinge into the polymer interface at  $NS = 250 \text{ mm/s}$ . Considering the electrical conductivity is directly related to the film thickness, this explains the poor electrical conductivity at  $NS > 200 \text{ mm/s}$ . Consequently, no electrical conductivity was achieved at  $NS > 250 \text{ mm/s}$ .

Fig. 3c presents the effect of the SD on electrical resistance at two different pressure levels. Regardless of gas pressure, the resistance tends to increase with larger spray distances ( $SD > 10 \text{ mm}$ ). This increase is attributed to the opposing drag force at higher spray distances resulting in a significant decrease in the particles' impact velocity [47], resulting in a sparse surface deposition (Fig. 4e). This effect can be compensated by increasing the gas pressure, potentially leading to enhanced material consolidation on the polymer surface, as shown in Fig. 4f. The film thickness decreased with the increase of the SD, leading to higher electrical resistance at greater SD. Cross-section SEM analysis in Fig. S5b (Supporting Information) confirmed the poor particle impingement into the polymer interface at  $SD = 30 \text{ mm}$ . Further increase in the SD beyond 30 mm resulted in disruptive particle deposition with no stable electrical conductivity (Fig. 3c). Notably, we observed lower electrical resistance at  $SD = 10 \text{ mm}$  as compared to  $SD = 5 \text{ mm}$ , suggesting that there is an optimal focal point to achieve more compact surface deposition. A SD shorter than a certain threshold often generates strong shock waves (*i.e.*, bow-shock) upon the impact of the supersonic gas jet, leading to nonuniform surface deposition [48,49]. Based on these findings along with the high-electrical conductivity and uniform metallization, the optimal CS settings were identified at  $P = 0.7 \text{ MPa}$ ,  $T = 80 \text{ °C}$ ,  $NS = 100 \text{ mm/s}$ , and  $SD = 10 \text{ mm}$ . The EDX analyses confirmed the effective and uniform distribution of the Sn particles over the polymer surface at the optimal CS settings (see Fig. S6, Supporting Information).

**Table 2**  
Process parameters of the material extrusion 3-D printing.

| Process parameters                                  | Value |
|---|-------|
| Filament diameter (mm)                              | 1.75  |
| Bed temperature (°C)                                | 60    |
| Extruder temperature (°C)                           | 200   |
| Infill density (%)                                  | 80    |
| Layer height (mm)                                   | 0.2   |
| Print speed ( $\text{mm}\cdot\text{s}^{-1}$ )       | 40    |
| First layer speed ( $\text{mm}\cdot\text{s}^{-1}$ ) | 10    |

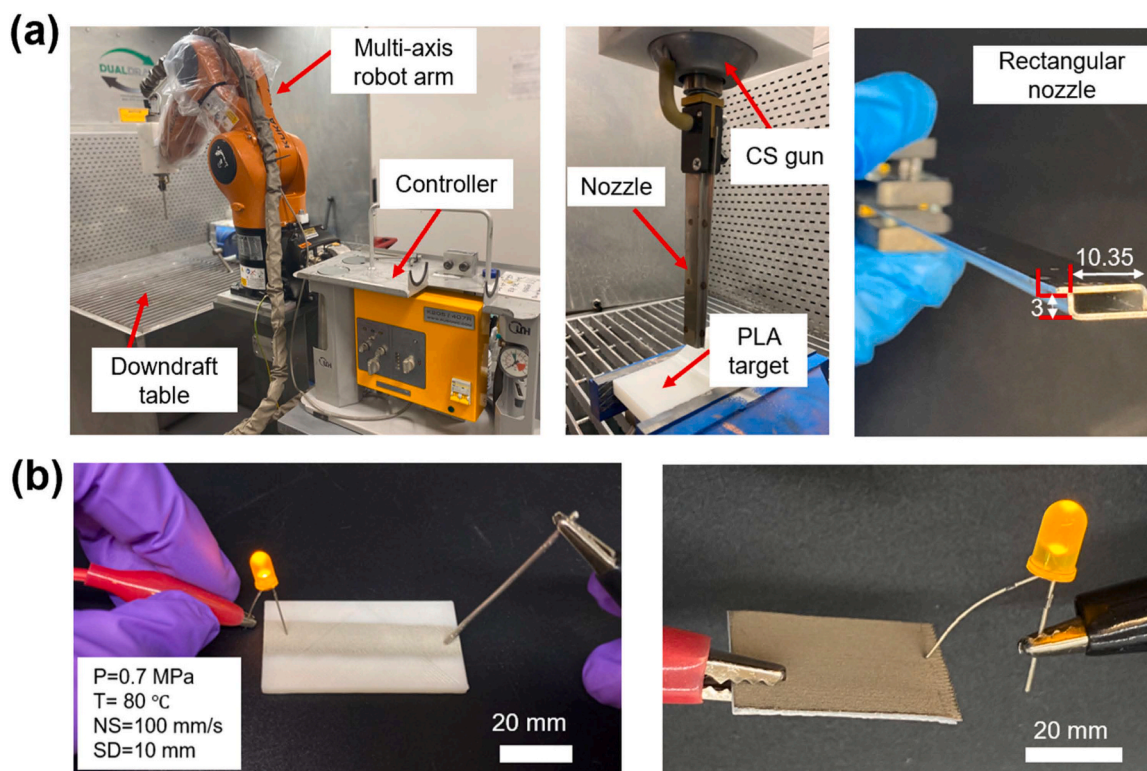


Fig. 2. Representative images of the (a) CS setup; (b) conductively metallized 3D-printed PLA parts.

Table 3

Process settings of the cold spray.

| Process parameters                            | Value                   |
|---|-------------------------|
| Working gas                                   | Air                     |
| Gas inlet pressure (MPa)                      | 0.6, 0.7                |
| Gas temperature (°C)                          | RT, 80, 120, 150        |
| Nozzle transverse speed (mm.s <sup>-1</sup> ) | 100, 150, 200, 250, 300 |
| Spray distance (mm)                           | 5, 10, 20, 30, 40       |
| Number of spray pass                          | 1                       |
| Powder feed rate (g.s <sup>-1</sup> )         | 0.2                     |

### 3.2. Electrical performance

The electrical conductivity of the electrodes was calculated by using Eq. 1, where  $\rho$  is the conductivity,  $R$  is the resistance, and  $A$  is the cross-sectional area of the electrode. The length, width, and average thickness of the electrodes are  $25 \times 10^{-3}$  m,  $20 \times 10^{-3}$  m, and  $142 \mu\text{m}$ , respectively. The average electrical resistance ( $R$ ) of the electrode test units was measured as  $0.09 \Omega$  (see Fig. 3a). Collectively, the electrical conductivity of  $9.8 \times 10^4 \text{ S.m}^{-1}$  was achieved for the Sn electrodes, which is only two orders of magnitude lower than the bulk conductivity of Sn (*i.e.*,  $9.17 \times 10^6 \text{ S.m}^{-1}$ ). This promising conductivity can be attributed to material consolidation and minimal porosity under the optimal CS processing conditions.

$$\sigma = \frac{L}{RA} \quad (1)$$

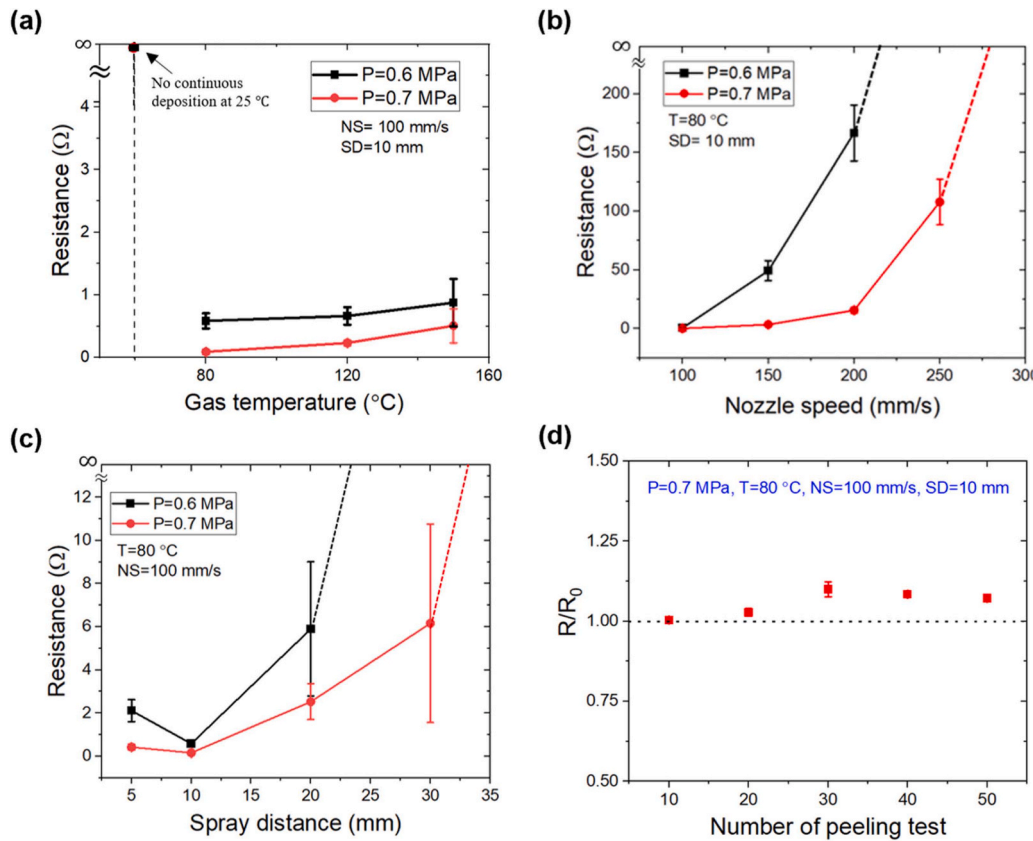
We also investigated the relationship between the adhesive strength and electrical stability of the fabricated electrodes by using the Scotch tape test method [21,50]. Fig. 3d shows the corresponding resistance of the electrodes under various Scotch tape (3 M magic tape) peeling cycles for the test units (*i.e.*, conduction path in a size of  $25 \text{ mm} \times 20 \text{ mm}$ ). No significant change in the relative resistance ( $R/R_0$ ) was observed for the electrodes. The overall increase in  $R/R_0$  did not exceed 10 % during the peeling cycles, indicating both strong adhesive strength and electrical

stability. Further qualitative characterizations, including rigorous bending deformations, confirmed the strong interfacial adhesive strength between the fabricated electrodes and the substrate (see Video S1, Supporting Information). No structural delamination or compromise in electrical conductivity was observed in the fabricated electrodes under the harsh mechanical stimuli (Video S1).

The sheet resistance ( $R_s$ ) was also calculated to compare the electrical conductivity of the 3D-printed electrodes with the conventional electrodes such as FTO glass and ITO/PET (see Table 4). The  $R_s$  measurements indicate that the electrical performance of the polymer electrode is promising compared to the traditional electrodes commonly used in energy harvesting applications. Moreover, the CS-based electrode (*i.e.*, PLA/Sn) exhibits a larger surface roughness than other electrodes, which is a desirable feature in the field of TENG, as it enhances the active surface area, charge flow and charge trapping performance [2,51].

Besides, cyclic voltammetry (CV) tests were conducted to investigate the catalytic and electrochemical activity of the electrodes. In the CV tests, a three-electrode configuration was employed, consisting of: (i) Ag/AgCl with 3 M KCl as the reference electrode; (ii) Pt counter electrode, and (iii) different types of working electrodes (PLA/Sn, Al foil, ITO/PET, and FTO/glass) for performance comparison. The electrolyte (*i.e.*, acetonitrile solution with 10 mM LiI, 1 mM I<sub>2</sub>, and 0.1 M LiClO<sub>4</sub>) was prepared based on the past study [52], where the scan rate of the CV tests is  $50 \text{ mV.s}^{-1}$ . A representative image of the CV test setup is provided in Fig. S7 (Supporting Information).

Fig. 5 compares the CS electrode (PLA/Sn) over the traditional counterpart electrodes, including Al foil, FTO glass, and ITO/PET. As observed in the CV plot in Fig. 5a, the Sn electrode exhibited a considerably higher magnitude of reduction/oxidation curve compared to other electrodes, indicating a significantly enhanced catalytic activity. To further compare electrochemical performance at the electrode/electrolyte interface, the charge storage capacity (CSC) was calculated based on the past study [53]. The CSC quantifies and assesses the amount of charge that can be stored within the electrode material. As



**Fig. 3.** (a) Effect of the gas temperature and gas pressure; (b) Effect of the nozzle speed; (c) Effect of the spray distance on the electrical resistance of the resultant coating; (d) Relative resistance ( $R/R_0$ ) change of the electrodes under peeling tests; (The electrode length ( $L$ ) = 25 mm and width ( $w$ ) = 20 mm).

shown in Fig. 5b, the CSC of the Sn electrode ( $9.0 \pm 1.4 \text{ mC}\cdot\text{cm}^{-2}$ ) is significantly higher (up to 570 times as in Al) compared to the counterpart electrodes. This enhancement can reasonably be attributed to the enlarged electrochemical active surface area resulting from the micro-rough surface morphology of the PLA/Sn electrode. This phenomenon significantly enhanced the electrode's capability for charge interaction within an electrochemical cell, leading to a promising CSC for the PLA/Sn electrode.

### 3.3. Fabrication of the TENGs

The contact-separation mode TENG design was considered owing to its simple structure with facile fabrication as well as widespread acceptance in TENG literature [54]. As shown in Fig. 6a, the complete working cycle of a contact-separation mode TENG consists of four main steps. In the initial state, where there is no contact, charge transfer does not occur between the materials. When an input pressure is applied, the positive and negative layers come into contact, leading to charge polarization at the materials' surface. Upon releasing the load, the material starts separating from each other. This separation creates a potential difference between the positive and negative friction layers, driving electrons from the friction layers to the charge collectors (electrodes) through an external circuit. This process enables the cyclic conversion of applied external mechanical energy into electrical energy by the TENG.

In a vertical-contact separation mode TENG, the output voltage ( $V$ ) can be determined using Eq.2 [55], where  $Q$  is the transferred charge,  $S$  is the contact surface area,  $\sigma$  is the triboelectric surface charge density,  $d$  is the thickness of the layers,  $\epsilon$  is the relative dielectric constants of the triboelectric layers,  $\epsilon_0$  is the vacuum permittivity, and  $x$  is the distance between the layers (*i.e.*, separation distance).

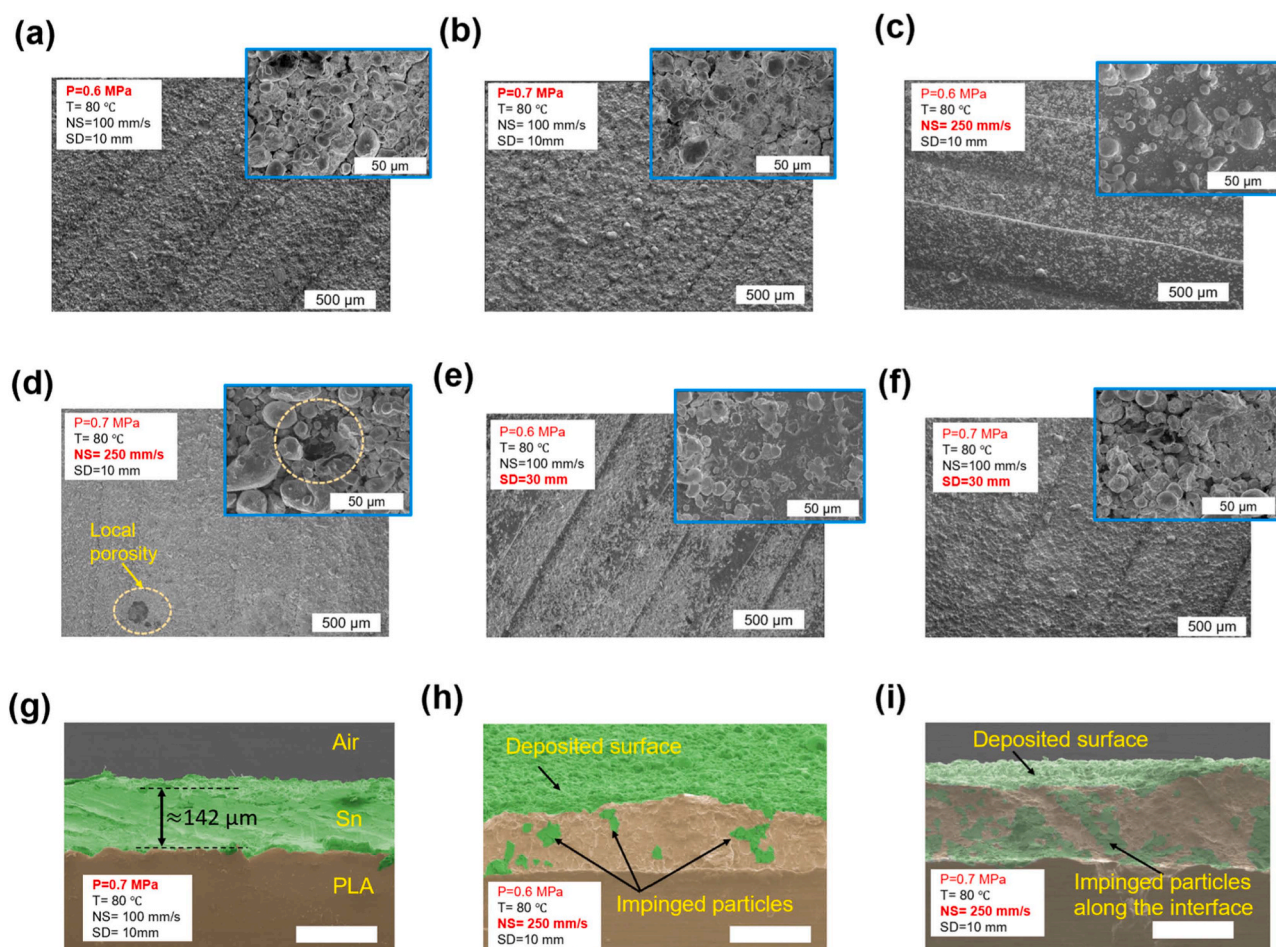
$$V = -\frac{Q}{S\epsilon_0} \left[ \frac{d_1}{\epsilon_{r1}} + \frac{d_2}{\epsilon_{r2}} + x(t) \right] + \frac{\sigma x(t)}{\epsilon_0} \quad (2)$$

Under the open-circuit conditions, where no charge transfer occurs (*i.e.*,  $Q=0$ ), the open-circuit voltage ( $V_{oc}$ ) can be calculated from Eq.3 as expressed below [55]. This  $V_{oc}$  depends on the triboelectric charge density, distance between the triboelectric layers, and the vacuum permittivity.

$$V_{oc} = \frac{\sigma x(t)}{\epsilon_0} \quad (3)$$

In our study, we designed and fabricated contact-separation mode TENGs using various material configurations for performance evaluation tests. A representative image of the fabricated TENG is shown in Fig. 6b, with PLA serving as the negative layer and CS/Sn acting as the back-electrode on the PLA surface. Additionally, the traditional Al electrode was employed in TENG devices as the control group for performance comparison. Fig. 6c presents the fabricated TENGs with various material configurations and their respective thickness for performance testing. 152  $\mu\text{m}$ -thick Al film was employed in control TENGs (*i.e.*, Design I and Design III) as it has a comparable thickness to the CS/Sn electrode (Fig. 4g). Both Design I and II utilize the Al film as the positive friction layer and electrode while the PLA polymer is the negative layer. The main distinction between Design I and II lies in the back-electrode of the negative triboelectric material (PLA). Specifically, Design I employs the Al film as the back-electrode while Design II incorporates the CS/Sn electrode. Subsequently, we compared the energy harvesting performance of TENGs with Design I and Design II, evaluating the CS/Sn electrode against the traditional Al electrode.

Furthermore, the PLA/Sn electrode was also tested as the back-electrode of the tribo-positive material. Considering the triboelectric series [56], PLA can favorably function as the tribo-positive material as



**Fig. 4.** Characterization of surface microstructure at various CS settings. (a–f) Surface microstructure; (g–i) Cross-section microstructure (The CS settings are provided in each figure within an enclosed white box).

**Table 4**

Electrical performance and surface roughness comparison of the fabricated electrode with other electrodes.

| Electrode material | Two-point resistance (R), ( $\Omega$ ) | Average sheet resistance, $R_s$ ( $\Omega/\text{sq}$ ) | Average surface roughness ( $R_a$ ), $\mu\text{m}$ |
|--------------------|--|--|--|
| CS Sn/PLA*         | $0.11 \pm 0.005$                       | $0.029 \pm 0.008$                                      | $6.316 \pm 0.867$                                  |
| FTO/glass          | $37 \pm 0.535$                         | 7 [66]   | $0.1718 \pm 0.071$                                 |
| ITO/PET            | $233.7 \pm 40$                         | 60 [67]  | $0.178 \pm 0.032$                                  |
| Al film            | $0.09 \pm 0.004$                       | 0.0034 [68]  | $0.3965 \pm 0.112$                                 |

it tends to lose electrons when in contact with another material, becoming positively charged. The triboelectric properties of materials like PLA have practical applications in the field of triboelectric energy harvesting, where the contact and separation of materials are harnessed to generate electricity [57]. For these experiments, as shown in Design III and IV (see Fig. 6c), the PTFE (Teflon) film was utilized as the negative layer due to its broad applicability in achieving stable and high-performance triboelectric energy harvesting [58]. The primary distinction between Design III and IV lies in their positive back-electrode, with Design III featuring an Al back-electrode, while Design IV incorporates the CS/Sn as the back-electrode for performance comparison. For all devices, polyimide (Kapton film, thickness = 1.25 mm) was used as the substrate material due to its inherent elasticity for the load cycles. The friction layers were prepared in dimensions of 25.4 mm  $\times$  25.4 mm, resulting in a triboelectric contact area is 645 mm<sup>2</sup>. The distance (gap) between the tribo-negative and

tribo-positive materials was kept constant at 25 mm. In all TENGs, the PLA substrate has a thickness of 1 mm.

### 3.4. Performance evaluation of the TENGs

The performance of the TENGs was tested by using a custom-build programmable pneumatic actuator coupled with an oscilloscope (see Fig. S8, Supporting Information). The surface area of the piston impacting the TENGs is 0.0058 cm<sup>2</sup> (i.e., 76.2 mm  $\times$  76.2 mm). The pneumatic air pressure was maintained at 30 psi ( $\approx$ 0.2 MPa) with an actuator frequency of 1 Hz (see Video S2). Fig. 7a depicts the open circuit voltage ( $V_{oc}$ ) generation of the TENGs. Initially, we conducted tests to compare the performance of the TENGs with Al foil as the positive layer and electrode (Design I-II). The TENG with the CS/Sn electrode (Design II) exhibited significantly better performance (i.e., peak-to-peak voltage generation) than the control TENG having the conventional Al back-electrode (Design I). The voltage generation was increased by 2.9-fold (i.e., from 32.76 V to 95 V) when employing the CS/Sn electrode as the negative back-electrode (see black and red lines in Fig. 7a). Furthermore, we also tested the Sn electrode as the back-electrode of the tribo-positive material (Design IV) against the TENG with Al back-electrode on the positive tribo-material of PLA (Design III). As shown in Fig. 7a (represented by blue and green lines), the peak-to-peak voltage generation improved by nearly 1.85-fold (i.e., from  $\approx$ 94 to  $\approx$ 174 V) compared to the control TENG (i.e., blue curve in Fig. 7a).

The TENG configurations in Fig. 6c were further characterized by employing a thinner Al foil (16  $\mu\text{m}$ -thick) as the back electrode against the as-CS Sn electrodes, as it falls within the widely used thickness range

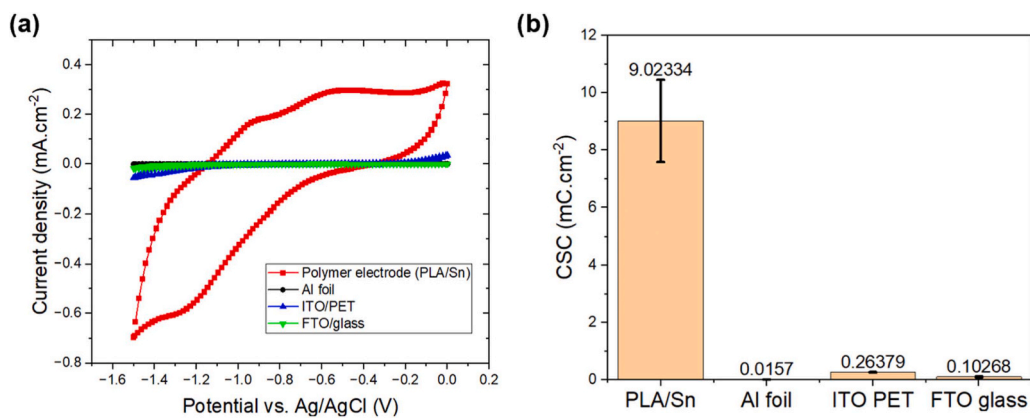


Fig. 5. (a) Cyclic voltammetry (CV) curves; (b) corresponding CSC values of the electrodes.

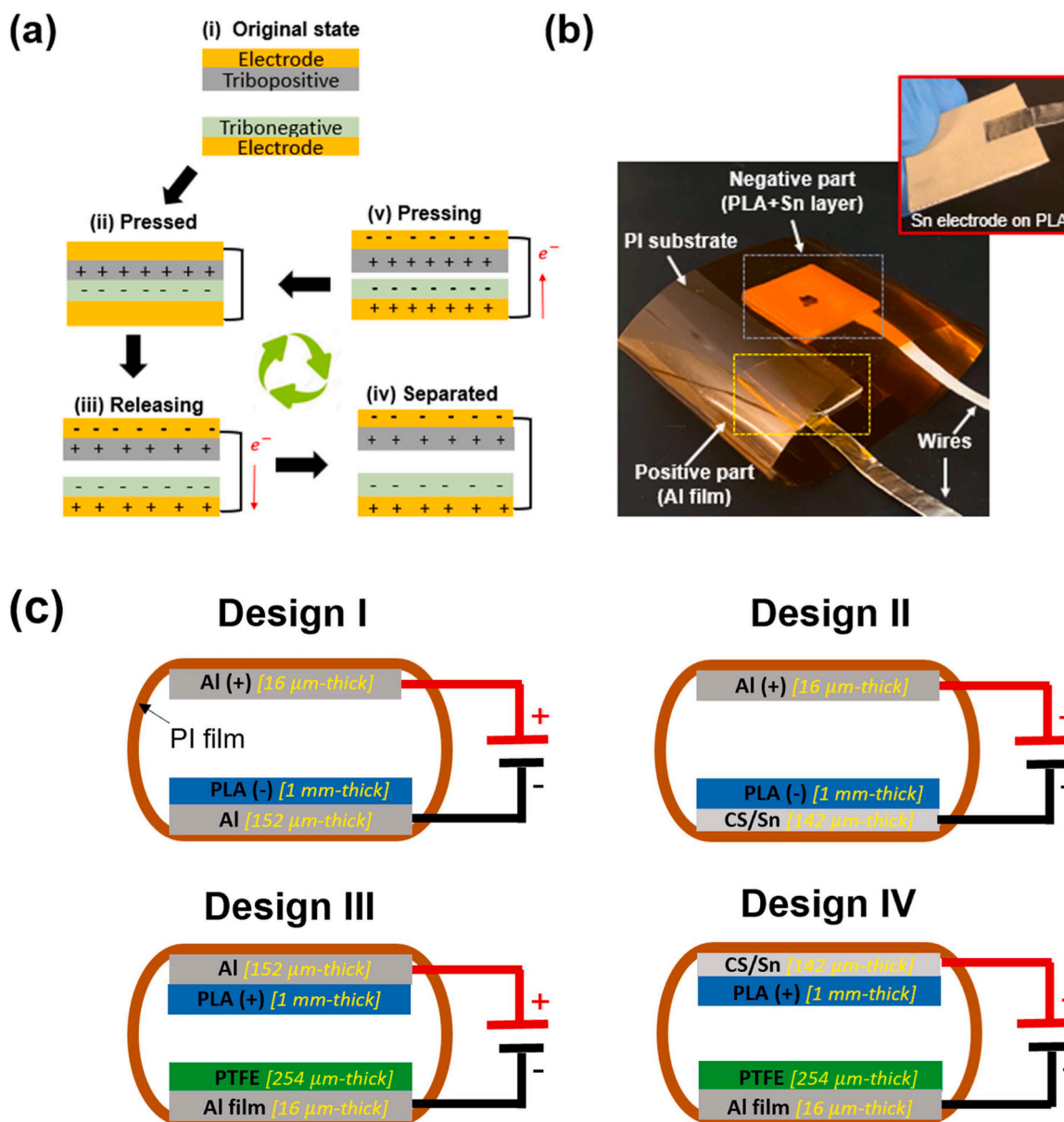


Fig. 6. (a) Schematic of the energy harvesting process in a full cycle of contact-separation mode TENG; (b) Representative image of the fabricated TENG with the PLA/Sn electrode; (c) Schematic of the TENGs with various material configurations.



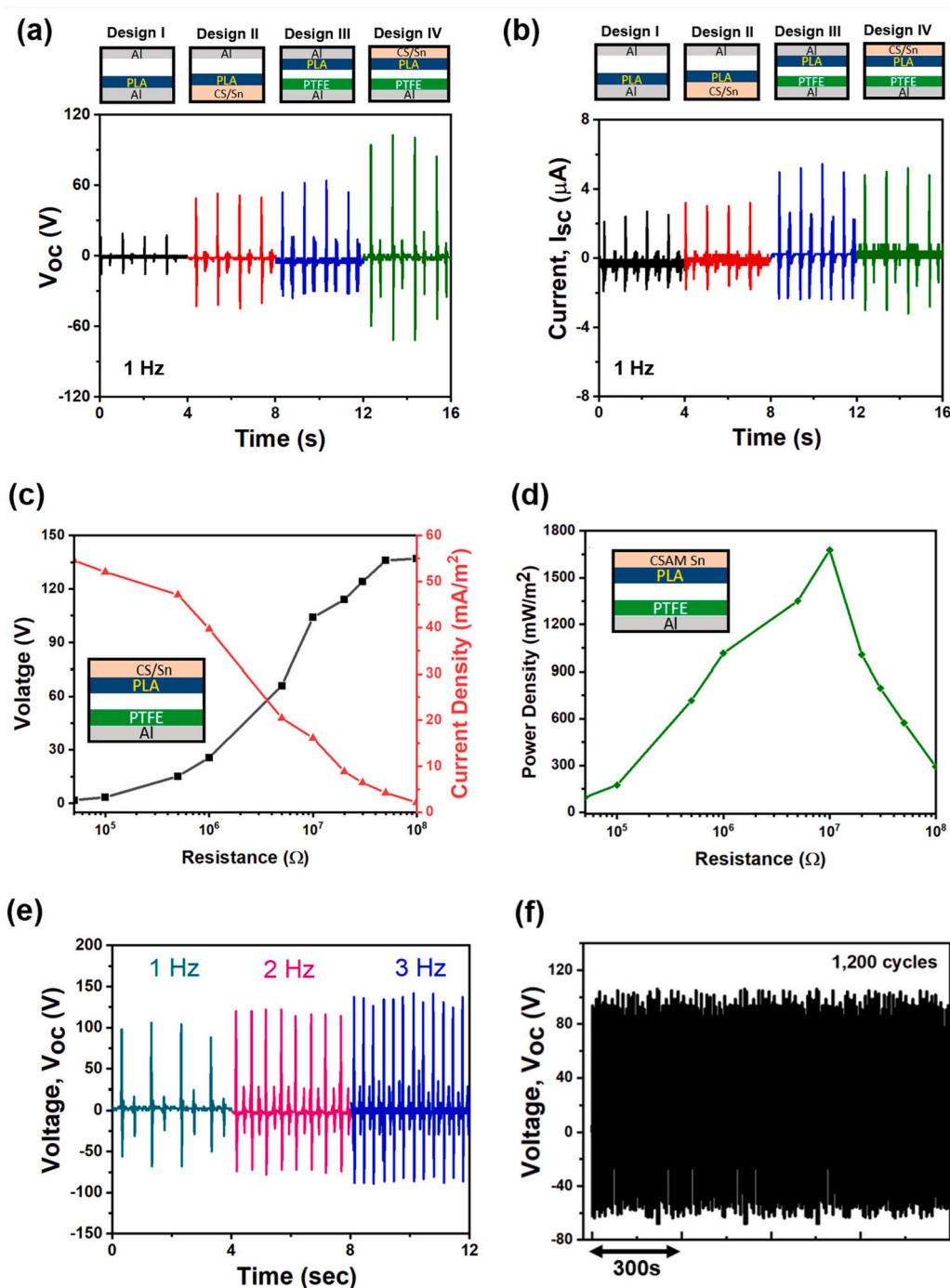


Fig. 7. (a) Open-circuit voltage; and (b) Output current; (c) Triboelectric output voltage and current density; (d) Power density; (e) frequency dependency; and (f) durability of the TENGs.

for back electrodes. The CS/Sn electrodes outperformed the 16  $\mu\text{m}$ -thick Al film, demonstrating 2.8-fold higher voltage generation performance. Further details regarding this characterization study are provided in the Supporting Information (Fig. S9). Consequently, the as-CS Sn electrodes outperformed the Al electrodes in TENGs with various material and thickness configurations.

The reasons behind this enhanced performance of the TENGs with the CS electrodes can be attributed to three factors: (i) improved charge flow at the interface between the PLA layer and Sn electrode due to the strong adhesive strength; (ii) the micro-rough surface morphology of the Sn electrode; and (iii) the positive charge density of the Sn electrode embedded within the 3D-printed PLA parts. The short-circuit current

( $I_{sc}$ ) measurement results in Fig. 7b also confirmed the improved current flow of the TENGs with the CS/Sn electrode. As for the surface roughness, the Sn electrode possesses significantly higher roughness ( $R_a=6.32 \mu\text{m}$ ) compared to the conventional Al electrode ( $R_a=0.23 \mu\text{m}$ ) (see Table 4). Increased surface roughness enhances the capacitance, dielectric constant, and dipole moment of the friction layers during the contact, leading to additional triboelectric charges [59]. The adhesion strength between the back-electrode and triboelectric layer is another critical factor influencing the TENG's output performance, as an optimal contact area is essential for maximizing charge accumulation and transfer [60]. Taken together, all these phenomena led to improved triboelectric synergy and charge trapping for the CS/Sn electrode.

We also investigated the effect of Sn electrode thickness on the TENG performance. The comparison of  $V_{oc}$  generation of the TENGs with varying electrode thickness is provided in Fig. S10 (Supporting Information). A quasi-linear relationship was observed between the film thickness and voltage generation, with increased film thickness leading to improved voltage generation in the TENG (Design IV) (Fig. S10c). This improvement is likely attributed to enhanced: (i) electrical conductivity due to the larger cross-section area; (ii) charge storage capacity due to its larger volume and increased capacitance. According to the resistivity formula (i.e.,  $R = \rho L/A$ ), the increased cross-sectional area decreases the electrical resistance. Consequently, the thicker Sn electrode allowed charge to flow more easily from the positive tribolayer to the back electrode, resulting in improved voltage generation performance.

Triboelectric voltage output and power generation were also characterized for the TENGs (Design IV), which features the Sn electrode as the back-electrode of the tribo-positive side. The TENG was connected to a rectification bridge and a series of resistors (see Fig. S11, Supporting Information) to obtain DC voltage, current density, and power density curves at various load resistance, ranging from 50 k $\Omega$  to 100 M $\Omega$ . Fig. 7c-d depict the voltage and power density of the TENG at various external load resistances. As expected from Ohm's law ( $V=IR$ ), the output voltage increased with increasing resistance, while the current decreased. The maximum voltage was obtained as 137 V at the load resistance of 100 M $\Omega$ . Regarding current density measurements, the TENG exhibited a maximum current density of  $\approx 55$  mA/m<sup>2</sup> at the load resistance of 50 k $\Omega$  (Fig. 7c). The maximum power density of  $\approx 1676$  mW/m<sup>2</sup> was achieved at a resistance of 10 M $\Omega$  (Fig. 7d).

To further study the performance of the TENG, the effect of excitation frequency on the open-circuit voltage was tested under the various working frequencies, as shown in Fig. 7e. As the frequency increased from 1 to 3 Hz, the peak output voltage consistently rose (i.e., 174 V at 1 Hz, 200 V at 2 Hz, 227 V at 3 Hz). This increase can be attributed to increased contact per unit time at higher frequencies, which in turn improved the charge transport between the friction layers and electrodes [61]. The stability and durability of the TENG were also tested at 1 Hz loading frequency, as shown in Fig. 7f. No significant deterioration in the TENG's performance was observed over a working duration of 1200 s (1200 cycles), confirming the robustness and mechanical durability of the TENG.

A TENG-driven LED circuit was also designed and tested to demonstrate the pragmatic application of the fabricated electrodes (Fig. S12, Supporting Information). The TENG was connected to a rectification bridge to convert the AC output into DC voltage (Fig. S12a). A 100nF capacitor was connected in parallel to the output load to be charged while TENG was hand tapped. By exerting a hand tapping force on the TENG around 15–20 times each time, 28 Light Emitting Diodes (LEDs) (each 2.0 volts) were effectively illuminated (Video S3 and Fig. S12b, Supporting Information).

Taken together, the results underscore the potential of the fabricated electrodes in enhancing the electricity harvesting performance of TENG. Notably, owing to its intrinsic electrical and mechanical properties with sustainable and facile manufacturing practices, electrodes fabricated on 3D-printed parts have the potential to serve as high-performance charge collectors in a broad array of cutting-edge energy harvesting and storage devices, including solar cells, lithium-ion batteries, supercapacitors, and more. Additionally, the established manufacturing platform could be adapted to produce polymer electronics for emerging fields such as surface-mounted devices and the Internet of Things (IoT), provided that the line resolution of the CS technique is enhanced.

While CS offers unique advantages such as high-throughput, low process temperature, adhesion strength, and corrosion resistance, it faces a challenge in spatial resolution compared to other printing techniques like inkjet and aerosol printing. This limitation stems from the nozzle dimensions of the CS equipment, which typically are around  $\phi$  mm for round nozzles and 10 mm  $\times$  3 mm for rectangular nozzles [62,

63]. Although micro-cold spray technologies have been developed for high-resolution patterning, they require a dedicated vacuum environment to deposit functional materials on the target surface [64]. Besides, shadowing masks were also proposed to improve the line resolution of the CS process on polymer targets [65]. However, these approaches limit the scalability of the CS process in polymer electronics, requiring specialized equipment and environments, which complicates the integration of CS into existing manufacturing lines. Consequently, there is a pressing need for innovative solutions to streamline the CS process, reduce dependency on specialized environments, and lower the barriers to fully exploit CS technology in the fields of TENG and polymer electronics. Accordingly, the next section is dedicated to a case study on a manufacturing innovation aimed at increasing the line resolution of the CS process without the need for dedicated masking and vacuum equipment.

### 3.5. Case study: CS-based manufacturing innovation for polymer electronics

A manufacturing pathway, as shown in Fig. 8, is proposed to improve the resolution of traditional CS, enabling the creation of free-form electronic circuitry on 3D-printed polymers. The manufacturing process can be summarized as follows: First, a customized circuitry, such as an LED display counter circuit, is designed (see Fig. S13, Supporting Information) and incorporated into the material extrusion 3-D printing process. This process involves the incorporation of groove patterns for precise circuitry design (Fig. 8, left panel). The grooves feature a 1 mm linewidth and 1.5 mm depth. Next, the surface of the 3D-printed part is metallized through CS particle deposition (Fig. 8, middle panel). The high-speed impingement of particles during the robotic-controlled CS process allows the particles to penetrate the grooves, forming electrically conductive metallization within these structures (see Video S4). Finally, the as-CS surface is polished to remove the Sn layer ( $\approx 0.5$  mm-thick) from the surface while retaining the electrodes inside the grooves (Fig. 9, right panel). This approach enables the creation of free-form high-resolution electrodes embedded into the 3D-printed part surface, ensuring consistent electrical conductivity (see Fig. 9a), which is essential for the development of 3-D plastronic devices.

The resulting custom-build electrodes can be utilized in surface-mount devices (SMD), enabling modular assembly of the circuits. In this context, an adjustable LED circuit was designed on the 3D-printed part (Fig. S13, Supporting Information). Various circuit components (e.g., resistor, capacitor, button, display) were assembled on the 3D-printed board by applying silver epoxy (MG Chemicals) to the junction points (Fig. 9a). A DC power unit (Korad, KD6003D) was used to power the circuit with an input voltage of 12 V. Fig. 9b and Video S5 (Supporting Information) illustrate the implementation of an adjustable LED display counter circuit on the 3D-printed part in Fig. 8 (right panel), verifying the electrical functionality of the circuitry. As such, the case study demonstrates that the application scope of the CS can expand from large-area functional surface coatings to free-form, custom-designed electronics on 3D-printed polymers with line resolution of up to 1 mm. Notably, the resolution of the electrodes could be further enhanced by adopting high-resolution printing techniques such as vat polymerization. Furthermore, owing to the multi-axis robot arm compatibility of the CS process, functional surface structures on freeform 3-D printed parts (e.g., dome-shaped, convex-concave) can be effectively created without the need for dedicated vacuum equipment [65]. This capability further underscores the potential of this emerging manufacturing technique for processing intricate surface structures.

Besides, this approach could extend beyond 3D-printed polymer parts to various commercial thermoplastic polymers, including ABS, PETG, PEEK, and more. Fig. S14 demonstrates the electrodes fabricated on 3D-printed ABS and PETG, illustrating consistent and promising electrical conductivity. Unlike the conventional polymer metallization techniques, CS writing could eliminate the need for chemical etching,

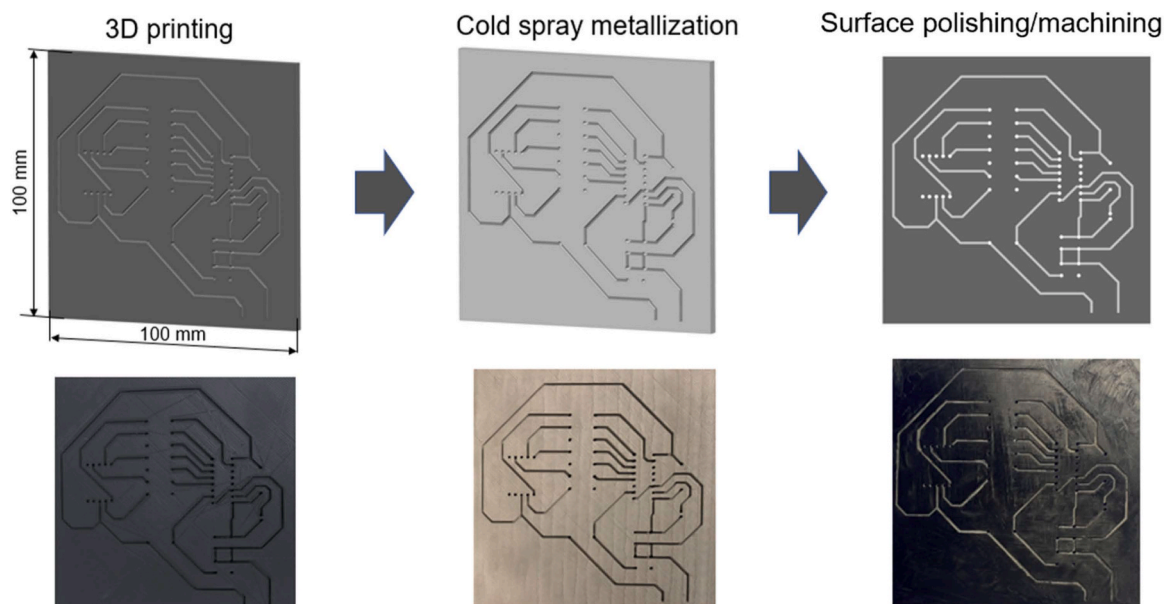


Fig. 8. A manufacturing pathway for CS-based polymer electronics; schematics (top panel) and representative images (bottom panel).

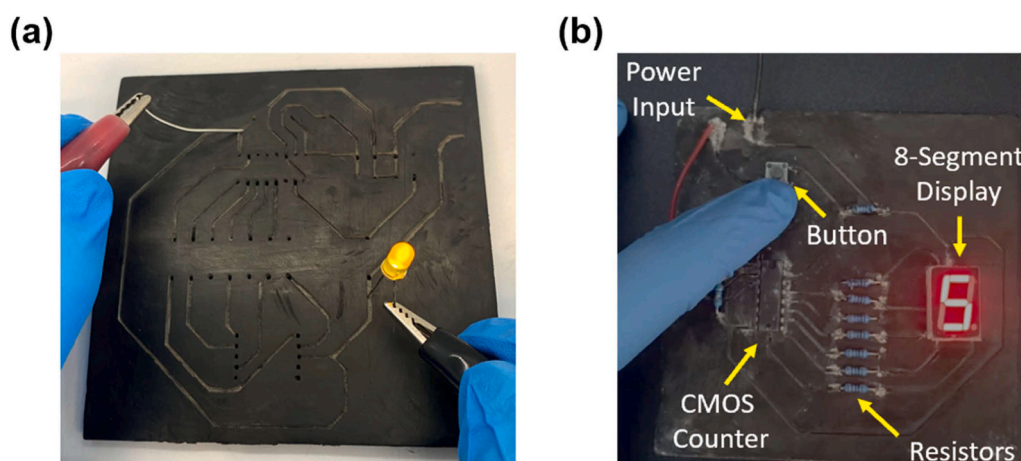


Fig. 9. (a) Fabricated custom-designed electrodes embedded into the 3D-printed part; (b) Representative image of the LED display counter on the 3D-printed part.

palladium (Pd) seeding, and post-curing processes, making it an eco-friendly choice for 3D-printed electronics. Given the high interest in integrating electronics, sensors, and energy harvesting devices for IoT and Industry 4.0, this approach offers a robust solution for creating 3D-printed parts with integrated electronic circuits.

#### 4. Conclusion

We employed a complete AM approach for creating functionalized electrodes on 3D-printed parts, specifically tailored for triboelectric energy harvesting applications. In this approach, we integrated material extrusion 3D printing and the CS technique to develop high-performance functional electrodes. First, the polymer PLA substrates were 3D printed. Next, the conductive electrodes were directly written on the polymer surface by the CS. Process-structure-property relationships of the CS were uncovered for one-step fabrication of functionalized electrodes on 3D-printed polymer parts for TENG applications. Furthermore, a manufacturing pathway was proposed to address the low-spatial resolution of the CS metallization, aiming to achieve polymer electronics with high-line resolution. The following conclusions can be drawn:

- Unlike the traditional polymer metallization techniques, the AM approach in this work eliminates the need for chemical-etching, masking, precursor, or vacuum processes, thereby offering potential for sustainable manufacturing of functionalized electrodes on 3D-printed parts.
- The resulting electrodes exhibited promising characteristics, including electrical conductivity ( $9.8 \times 10^4 \text{ S.m}^{-1}$ ), surface roughness ( $R_a = 6.32 \mu\text{m}$ ), adhesive strength, charge storage capacity ( $9.0 \pm 1.4 \text{ mC.cm}^{-2}$ ), and stability.
- The TENGs with the fabricated electrodes led to significantly higher energy harvesting performance ( $\approx 1.85\text{--}2.9\text{-fold}$ ) than that of the control TENGs.
- The TENG with the CS electrode (PLA/Sn) can achieve the maximum open-circuit output voltage of 174, the short-circuit density of  $\approx 55 \text{ mA/m}^2$ , and the power density of  $1676 \text{ mW/m}^2$ .
- A manufacturing strategy combining material extrusion 3D printing with CS and subsequent surface machining enhanced electrode line resolution to 1 mm.
- The results reveal that the established AM platform holds significant promise for advancing the field of TENG and polymer electronics by

addressing the limitations of traditional electrode manufacturing techniques.

### Supporting information

Figs. S1–S14 show the feasibility test of CS Al deposition on 3D-printed PLA; IR camera images of the nozzle at various gas temperature settings; photographs and SEM images of the as-CS specimens; cross-section SEM images of the as-CS specimens; EDX results of the fabricated electrodes; image of the CV test setup; the image of the pneumatic actuator used in the TENG characterization; the voltage output results of the TENGs for additional characterizations; the schematic of the full-bridge rectifier used in the TENG tests; the images of the TENG-driven LED circuit; and circuit diagram of the LED display counter; the images of the as-CS Sn electrode on 3D-printed ABS and PETG parts.

### Author contributions

The manuscript was written through contributions of all authors. All authors have given approval to the final version of the manuscript.

### CRediT authorship contribution statement

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### Declaration of Competing Interest

The authors declare the following financial interests/personal relationships which may be considered as potential competing interests: Martin Jun & Semih Akin has patent Cold spray printed flexible electronics and method for manufacturing the same pending to Purdue Research Foundation (West Lafayette, IN, US). If there are other authors, they declare that they have no known competing financial interests or personal relationships that could have appeared to influence the work reported in this paper.

### Data Availability

Data will be made available on request.

### Appendix A. Supporting information

Supplementary data associated with this article can be found in the online version at [doi:10.1016/j.nanoen.2024.110082](https://doi.org/10.1016/j.nanoen.2024.110082).

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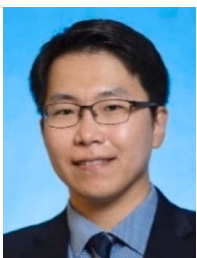
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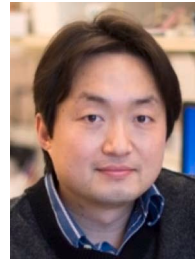
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